



PATENT

Attorney Docket No. AUI3-06300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Yonhua Tzeng
Serial No.: 10/772,740
Filed: February 5, 2004
For: **METHOD OF PLASMA
ENHANCED CHEMICAL
VAPOR DEPOSITION OF
DIAMOND USING METHANOL-
BASED SOLUTIONS**

Group Art Unit: 1762

Examiner: Stouffer, Kelly M.

**POWER OF ATTORNEY AND
REVOCATION OF PRIOR
POWERS OF ATTORNEY**

Customer No.: 28960

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Auburn University owner of record of this application, hereby revokes all prior powers of attorney which may have been filed with this patent, and appoints the members of the firm of HAVERSTOCK & OWENS LLP, a firm including Jonathan O. Owens (Reg. No. 37,902) and Thomas B. Haverstock (Reg. No. 32,571), as its attorneys with full power of substitution to transact all business in the Patent and Trademark Office in connection therewith.

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Dated:

5/11/07

By:

Name:

Title:

Jan D. Thornton
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Director, Office of Technology
Transfer